

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT application of	) Confirmation No. 9528
Koichiro TANAKA	)
Application No. 10/769,820	) Group Art Unit: 1725
Filed: February 3, 2004	) Examiner: Samuel Heinrich
	)
For: LASER IRRADIATION STAGE, LASER	)
IRRADIATION OPTICAL SYSTEM,...	) November 8, 2006

**INFORMATION DISCLOSURE STATEMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98.

The Commissioner is authorized to charge the amount of \$180.00 to Deposit Account No. 19-2380 in compliance with the provisions of 37 C.F.R. § 1.97(c).

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner-initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

/John F. Guay, Reg.# 47248/  
John F. Guay

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